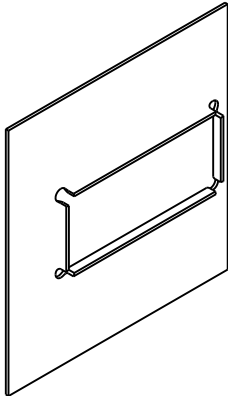
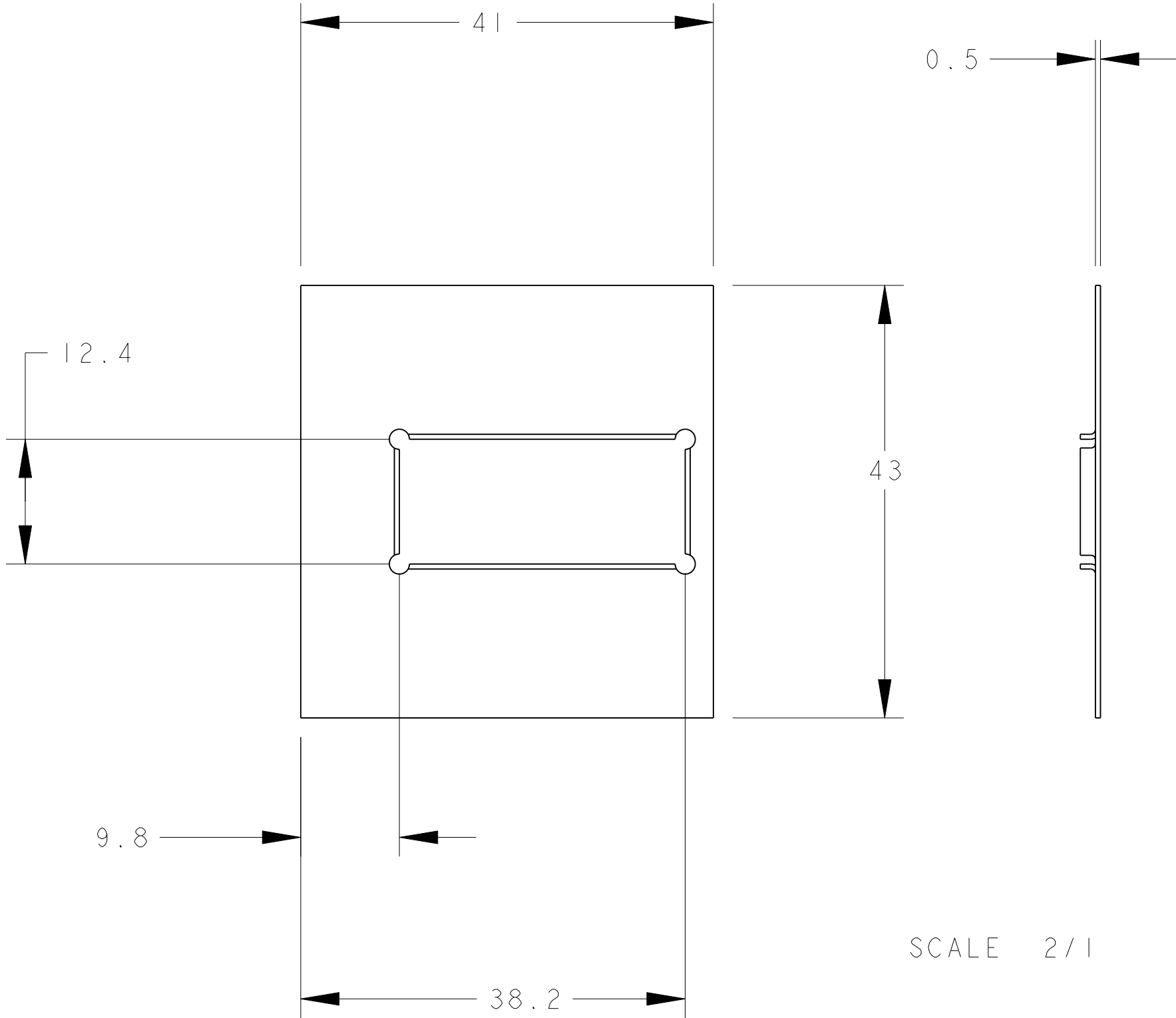


						UNLESS OTHERWISE SPECIFIED		SHOP ORDERS		SER NO. -	ERNEST ORLANDO LAWRENCE BERKELEY NATIONAL LABORATORY UNIVERSITY OF CALIFORNIA - BERKELEY ATLAS PIXEL DETECTOR PIXEL SUPPORT TUBE MOUNT BLOCK INSULATOR SHIM				
						TOLERANCES	X.X ± 0.5	FRAC. ± 1/64	ACCT NO.	NO. REQD					DATE ISSD -
							X.XX ± 0.05	Angles ± 1.00°	DEL TO	DATE REQD -					
							X.XXX ± 0.010	FINISH $\sqrt[125]{(\mu in.)}$	SURFACE TREATMT -						
						DO NOT SCALE PRINT		IDENT METHOD TAG	US ATLAS SILICON SUBSYSTEM (11pgs)						
						THREADS ARE CLASS 2		PROJECT NUMBER N/A							
						CHAMFER ENDS OF ALL SCREW TREADS 30°		PROJECT NAME US ATLAS SILICON SUBSYSTEM							
						CUT ROUND, 1.5 THREAD RELIEF ON MACHINED THREADS		DWG BY ANDERSSSEN	DATE 15-Feb-03	MICROFILMED:		DWG. TYPE PART	SHOWN ON	SCALE: 1/1	DO NOT SCALE PRINTS
						BREAK EDGES .016 MAX. ON MACHINED WORK		CHK BY HARTMAN	DATE	PATENT CLEAR:		DESIGN ACCT. NO. PIAP11	CATEGORY CODE AP6300	SHEET 1 OF 1	
						REMOVE BURRS, WELD SPLATTER & LOOSE SCALE		APR BY GILCHRIESE	DATE					DWG. NO. 2501203	SIZE
						IN ACCORDANCE WITH ASME Y14.5M & B46.1								REV.	
REV	DWG	CHK	ZONE	DATE	CHANGES										



SCALE 2/1

DESCRIPTION	MATERIAL	MAT. LOCATION
-	AQ10 EX1515	-